

Supporting Information for

Inorganic CsBi₃I₁₀ Perovskite/Silicon Heterojunctions for Sensitive, Self-driven and Air-Stable NIR Photodetectors

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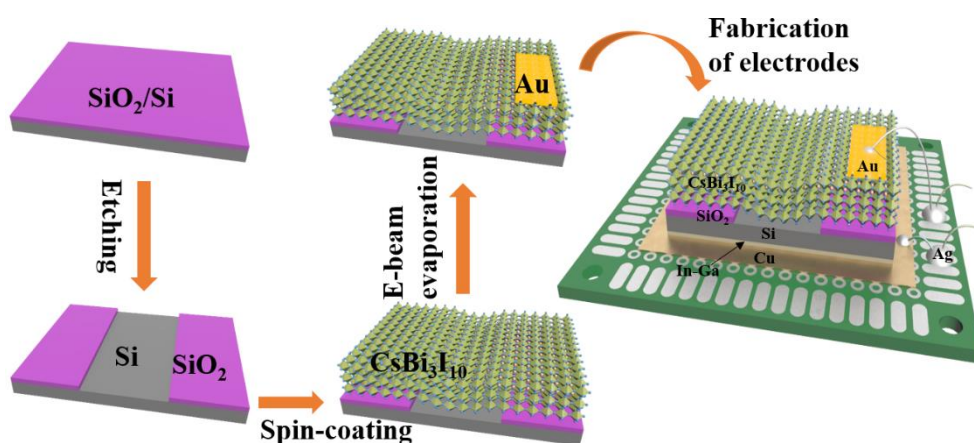


Figure S1. Schematic illustration of fabrication procedure of the CsBi₃I₁₀ perovskite/Si heterojunction photodetector.

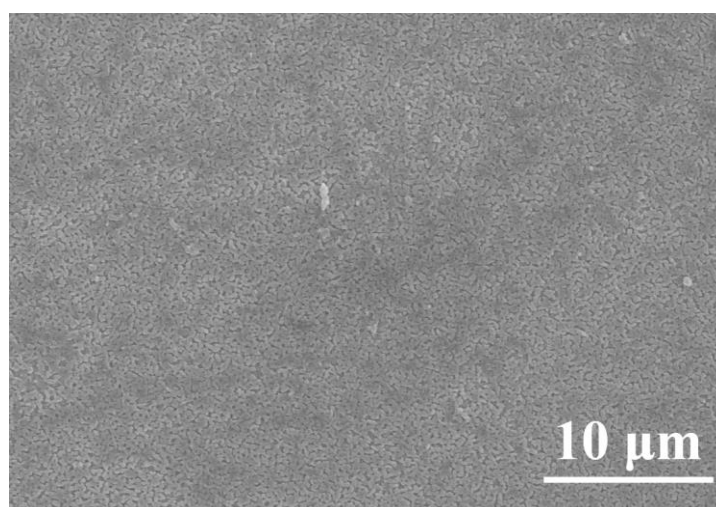


Figure S2 A top-view SEM image of CsBi₃I₁₀ film.

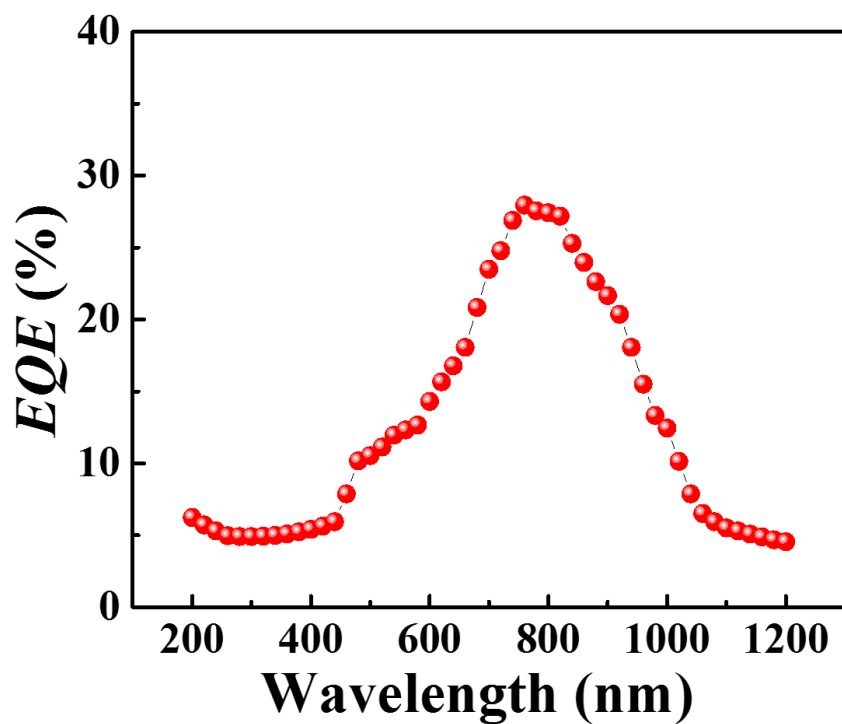


Figure S3 EQE of $CsBi_3I_{10}$ perovskite/Si heterojunction photodetector with different wavelength.

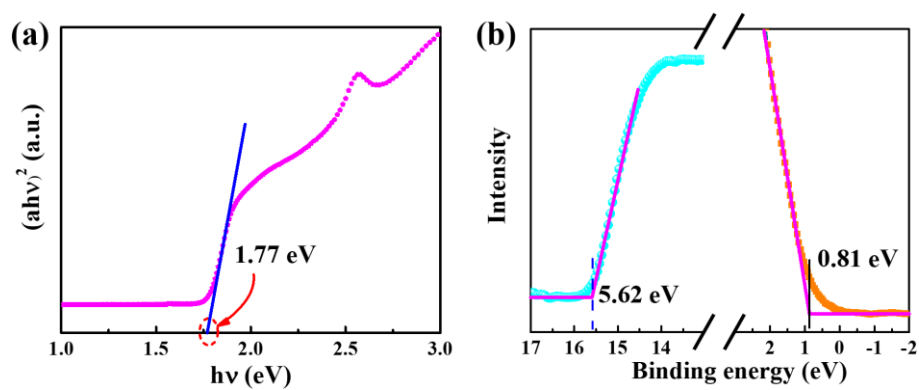


Figure S4 (a) The dependence of $(ah\nu)^2$ on $h\nu$ for the $CsBi_3I_{10}$ perovskite, from which the band gap of ~ 1.77 eV was deduced. (b) UPS spectrum of the $CsBi_3I_{10}$ perovskite film.

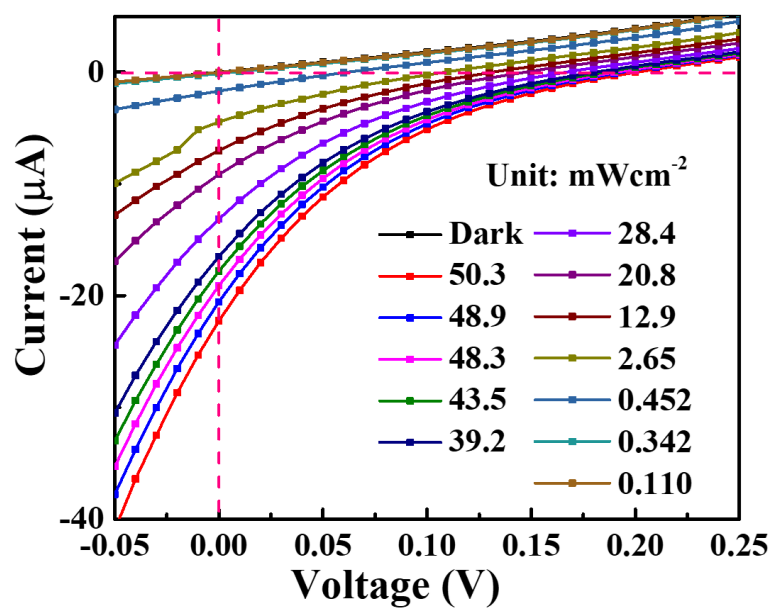


Figure S5 I - V characteristics of $\text{CsBi}_3\text{I}_{10}$ perovskite/Si heterojunction photodetector in dark and under 808 nm light illumination with varied light intensities.

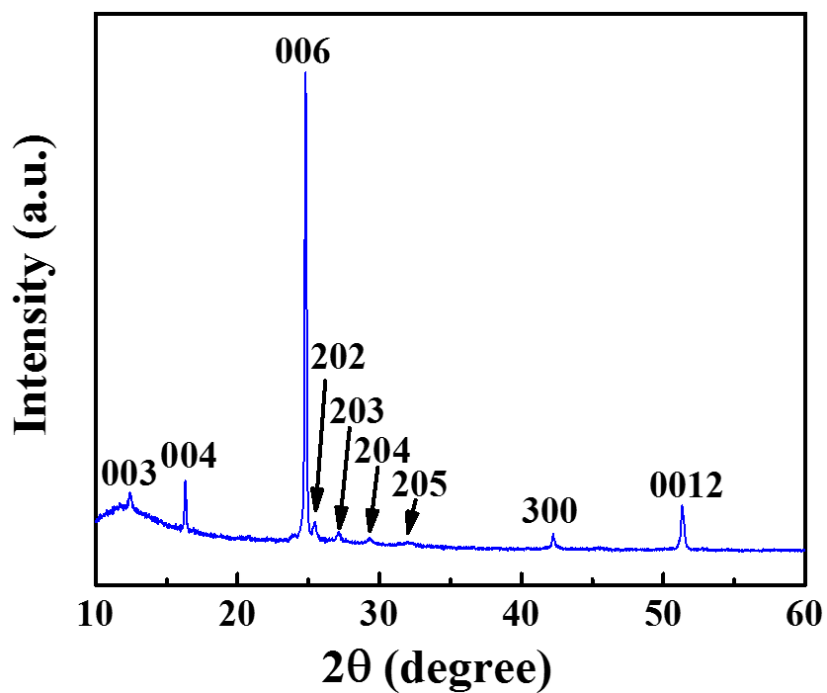


Figure S6 XRD pattern of the $\text{CsBi}_3\text{I}_{10}$ perovskite film after 3 months storage.